

APPLICATION DATA SHEET

Applicants: 1st Inventor: Angela T. Hui
Residence: 362 Pilgrim Loop
Fremont, Alameda County, California 94539
Mailing: Same as above

2nd Inventor: Jusuke Ogura
Residence: 10183 Denison Avenue
Cupertino, Santa Clara County, California 95014

3rd Inventor: Yider Wu
Residence: 218 W. Rincon Avenue
Campbell, Santa Clara County, California 95008

Correspondence: Kelly K. Kordzik
Winstead Sechrest & Minick P.C.
P.O. Box 50784
Dallas, Texas 75201

Application Information: Title: AVOIDING FIELD OXIDE GOUGING IN SHALLOW
TRENCH ISOLATION (STI) REGIONS
Classification: Class: Subclass:
Tech Center:
Drawing Sheets: 3 Drawing to be Published:
Docket No: AF01158
Type: Utility
Secrecy: None

Representative Information: Kelly K. Kordzik, Reg. No. 36,571
Robert A. Voigt, Jr., Reg. No. 47,159
Richard F. Frankeny, Reg. No. 47,573

Domestic Priority:

Application:	Continuity Type:	Parent Application:	Parent Filing Date:
None			

Foreign Priority Information

Country:	Application Number:	Filing Date:	Priority Claimed:
None			

Assignee: FASL LLC
One AMD Place
P.O. Box 3453
Sunnyvale, CA 94088